



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399
First Named Inventor : Yoshihiro KATO
Filed : July 22, 2003
TC/A.U. : 1763
Examiner : J. Lund

Docket No. : 101246.52582US
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

REPLY

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following proposed amendments and remarks are respectfully submitted in response to the final Office Action dated January 16, 2007, the period for response having been extended to May 16, 2007 by the attached Petition for Extension of Time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. ***No additional claims fees are due.***

Remarks begin on page 10 of this paper.